IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Tatsuya USAMI

Appl. No.:

NEW NON-PROVISIONAL

Group:

Filed:

January 28, 2004

Examiner:

For:

SEMICONDUCTOR DEVICE WITH IMPROVED

RELIABILITY AND MANUFACTURING METHOD OF

THE SAME

INFORMATION DISCLOSURE STATEMENT
(SUBMISSION CONCURRENT WITH THE
FILING OF A NEW PATENT APPLICATION)

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

January 28, 2004

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, and in fulfillment of the duty of disclosure under 37 C.F.R. § 1.56, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

## I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications, or other information submitted for consideration by the Office are listed on PTO-1449, attached hereto.

## II. COPIES

Ш					ublications			
	since filed			their	submission	n for	app	olications

- Submitted herewith is a legible copy of (i) each foreign patent; (ii) each publication or that portion which caused it to be listed; and (iii) all other information or that portion which caused it to be listed.
- This application is a National Phase of a PCT application. Some or all of the documents listed on the PTO-1449 are not enclosed because they were cited in the International Search Report and copies should have been forwarded from the International Search Authority pursuant to the trilateral agreement between the USPTO, EPO and JPO, or they are U.S. patents or U.S. published applications. If copies are needed, please contact the undersigned.

		Docket No. 8022-1067							
III. CONCISE EXPLANATION OF THE RELEVANCE (check at least one box)									
a. [	a. DOCUMENTS IN THE ENGLISH LANGUAGE								
	The attached patents, information in the Englis statement of relevancy.	publications, or other sh language do not require a							
b. 🛭	DOCUMENTS NOT IN THE ENGI	ISH LANGUAGE							
	patents, publications, o	of the relevance of all or other information listed the language is as follows:							
	Cited on pages 3, 7, specification	8, and 9 of the present							
c.									
	An English language vers action that indicates th by the foreign office satisfying the requiexplanation. See MPEP 609	rement for a concise							
d. [	OTHER								
The following additional information is provided for the Examiner's consideration.									
<u>FEES</u>									
This Information Disclosure Statement is being filed concurrently with the filing of a new patent application; therefore, no fee is required.									
If The Examiner has any questions concerning this IDS, he/she is requested to contact the undersigned.									
Respectfully submitted,									
YOUNG & THOMPSON									
hant Castel									

745 South 23<sup>rd</sup> Street Arlington, VA 22202 Telephone (703) 521-2297

Benoit Castel, Reg. No. 35,041

Enclosures:

BC/ma

 $\boxtimes$ Form PTO-1449(s)

 $\boxtimes$ Documents

Foreign Search Report

Other:\_\_\_\_

INFO	DRMATION DISCLOSURE	CITATION	Attorney Docket No.: 8022-1067	Application No.: NEW NONPROVISIONA					
	IN AN APPLICATIO	N	Applicant: Tatsuya USAMI						
-	(Use several sheets if necess	Filing Date:  January 28, 2004		Group Art Unit:					
		U.S. PATEN	T DOCUMENTS	<del></del>					
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		FOREIGN PAT	ENT DOCUMENTS		<del></del>				
Examiner Initial	Document Number	Date	Date Country		ss Subclass		slation		
	2003-17561	1/17/2003	JAPAN			Yes	No		
	11-87502	3/30/1999	JAPAN						
	2000-294634 2001-326222	10/20/2000	JAPAN			<u> </u>			
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<sup>\*</sup> Abstract provided for the Examiner's convenience